

**Amendment and Response**

Applicant: Willard Charles Raymond

Serial No.: 10/622,850

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Docket No.: A126.116.102

Title: ADJUSTABLE WAFER ALIGNMENT ARM

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**IN THE SPECIFICATION**

Please replace the paragraph beginning at page 5, line 15 with the following rewritten paragraph:

The contact elements 40 are mounted to the respective support arm 32 or 34 so as to be horizontally moveable (relative to the orientation of Figures 1 and 2). For example, the contact elements 40 are secured to or about a shaft that is otherwise extendably connected to the respective support arm 32 or 34 as shown in Figure 3A. Alternatively, the contact elements 40 can be mounted to a support plate that is pivotally secured to the respective support arm 32 or 34 as shown in Figure 3B. Regardless of the exact mounting technique, and returning to Figures 1 and 2, a programmable drive mechanism (unnumbered in the Figures) is connected to the component otherwise supporting the contact elements 40 and dictates a desired horizontal position of the rollers 40 relative to the base arm 30 and/or the support arms 32, 34. For example, an actuator mechanism 44, such as a servo actuator, can be provided that, upon activation, horizontally extends/retracts the contact elements 40 to the desired location that is otherwise dictated by a diameter of the film frame 14 being handled.